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2823

PATENT  
97-CT-174

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
RAFFAELE ZAMBRANO	)	Group Art Unit: 2823
Serial No.: 09/191,743	)	
Confirmation No.: 8970	)	Examiner: M. Estrada
Filed: November 13, 1998	)	
For: IN-SITU DEPOSITION AND	)	
DOPING PROCESS FOR POLY-	)	
CRYSTALLINE SILICON LAYERS	)	
AND THE RESULTING DEVICE	)	
_____	)	

**CORRECTED AMENDMENT SECTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Non-Compliant Amendment dated February 25, 2004, in connection with the above-identified application, please enter and consider the following corrected section of the Amendment filed February 2, 2004.

I hereby certify that this correspondence is  
being deposited with the United States Postal  
Service with sufficient postage as first class  
mail in an envelope addressed to:  
Commissioner for Patents, P.O. Box 1450,

Alexandria, VA 22313-1450, on 3/25/04  
Date of Deposit

Stephen Bongini  
Applicant, Assignee, or Representative

[Signature] 3/25/04  
Signature Dated